



First Named Inventor	Kyle K. Kirby
Serial No.	10/613,235
Filing Date	July 3, 2003
Group Art Unit	2812
Examiner Name	Unknown
Confirmation No.	4763
Attorney Docket No.	400.231US01

Title: METHODS OF FORMING VIA PLUGS

INFORMATION
DISCLOSURE
STATEMENT

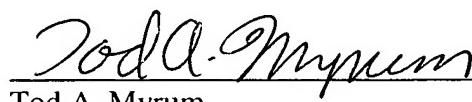
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

In compliance with 37 C.F.R. §§ 1.56 and 1.97, *et seq.*, the enclosed materials are brought to the attention of the Examiner for consideration in connection with the above-identified Application. Applicant respectfully requests that this Information Disclosure Statement be entered and the references listed on the attached Form 1449 be considered by the Examiner and made of record. Pursuant to MPEP §609, Applicant further requests that the Examiner initial next to each reference on the Form 1449 to indicate that the listed references have been considered. Applicant further requests that a copy of the initialed Form 1449 be returned with the next official communication.

As an Office Action has not yet issued in this application, Applicant believes that no fees are due. However, the Commission for Patents is hereby authorized to charge any additional fees to Deposit Account No. 501373. If the Examiner has any questions or concerns regarding this application, please contact the undersigned at the number listed below.

Respectfully submitted,

Date: 10-08-2003



Tod A. Myrum
Reg. No. 42,922

Attorneys for Applicant
Leffert Jay & Polglaze, P.A.
P.O. Box 581009
Minneapolis, MN 55458-1009

T - (612) 312-2200
F - (612) 312-2250



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**INFORMATION DISCLOSURE
STATEMENT
FORM PTO-1449**

Sheet 1 of 1

U.S. Patent References				
Examiner Initials	Document No.	Issue/Publication Date	Name	Filing Date
	6,251,488 B1	06-26-01	Miller	05-05-99
	6,288,442 B1	09/11/01	Farrar	09-10-98

Foreign Patent References				
Examiner Initials	Foreign Patent		Name	Publication Date
	Country	No.		
			.	

Other References	
Examiner Initials	Author, Title, Date, Pages, etc.
	B. King, M. Renn and M Essien, M ³ D Technology, Maskless Mesoscale™ Materials Deposition, "M ³ D Technology deposits electronic materials onto low-temperature, non-planar substrates without masks or resists," Optomec, Inc.
	M ³ D, Maskless Mesoscale™ Materials Deposition, Optomec, Inc.

Examiner Signature		Date Considered
*Examiner: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.		

Based on Form PTO-FB-A820 Patent and Trademark Office, U.S. Department of Commerce